NOTES:

- 1. SUBSTRATE MATERIAL: FUSED SILICA
- 2. COATING (APPLY ACROSS CLEAR APERTURE)

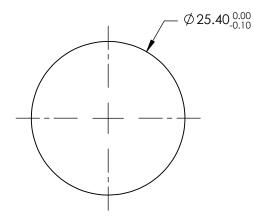
\$1: Ultrafast Laser R(AVG) >99% @ 333 - 353nm

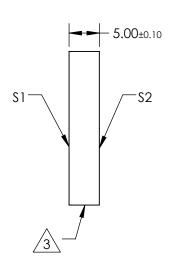
DAMAGE THRESHOLD, PULSED: 1000-on-1: >0.25 J/cm2, 100 fs, 100 Hz, @ 800 nm

S2: NONE



4. RoHS COMPLIANT





SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

REV. A	S1	\$2				Edmund Op	tice®
SHAPE	PLANO	PLANO					105
CLEAR APERTURE (%)	Ø22.86	N/A					
SURFACE QUALITY	20-10	COMMERCIAL POLISH			TITLE	333 - 353nm, 25.4mm Dia., Ultrafast Laser Line Mirror	
SURFACE FLATNESS	λ/8	N/A					i
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	85332	SHEET 1 OF 1

FOR INFORMATION ONLY: DO NOT MANUFACTURE PARTS TO THIS DRAWING